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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/657,867	09/09/2003	Kang-wook Park	SAM-0460 2097	
7590 08/08/2005			EXAMINER	
Steven M. Mills			LEWIS, MONICA	
MILLS & ONE	LLO LLP		<u> </u>	
Suite 605		·	ART UNIT	PAPER NUMBER
Eleven Beacon Street			2822	
Boston, MA 0	2108		DATE MAILED: 08/08/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)				
	10/657,867	PARK ET AL.	(hr			
Office Action Summary	Examiner	Art Unit				
	Monica Lewis	2822				
The MAILING DATE of this communication app Period for Reply	pears on the cover sheet with the c	orrespondence add	ress			
A SHORTENED STATUTORY PERIOD FOR REPL' THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a repl If NO period for reply is specified above, the maximum statutory period of Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be time y within the statutory minimum of thirty (30) days will apply and will expire SIX (6) MONTHS from the application to become ABANDONE.	nely filed s will be considered timely. the mailing date of this com D (35 U.S.C. § 133).	nmunication.			
Status						
1)⊠ Responsive to communication(s) filed on <u>06 M</u>	lay 2005.					
	action is non-final.					
3) Since this application is in condition for allowa	-					
Disposition of Claims						
4) ☐ Claim(s) 1-28 is/are pending in the application 4a) Of the above claim(s) 11-20 is/are withdray 5) ☐ Claim(s) 21-28 is/are allowed. 6) ☐ Claim(s) 1-9 is/are rejected. 7) ☐ Claim(s) 10 is/are objected to. 8) ☐ Claim(s) are subject to restriction and/o	vn from consideration.					
Application Papers						
9) ☐ The specification is objected to by the Examine 10) ☑ The drawing(s) filed on 09 September 2003 is/ Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct 11) ☐ The oath or declaration is objected to by the Ex	are: a) \square accepted or b) \square objection drawing(s) be held in abeyance. See tion is required if the drawing(s) is objection is required if the drawing(s) is objection.	e 37 CFR 1.85(a). jected to. See 37 CFF	R 1.121(d).			
Priority under 35 U.S.C. § 119						
a) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Burea * See the attached detailed Office action for a list	is have been received. is have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)).	on No ed in this National S	Stage			
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	4) Interview Summary Paper No(s)/Mail Da 5) Notice of Informal P 6) Other:		152)			

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DETAILED ACTION

1. This action is in response to the amendment filed May 6, 2005.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1-3 and 6 are rejected under 35 U.S.C. 103(a) as obvious over Ryum et al. (U.S.

Publication No. 2002/0058388) in view of Arai (U.S. Publication No. 2004/023526).

In regards to claim 1, Ryum et al. ("Ryum") discloses the following:

- a) a semiconductor substrate (1) of a first conductivity type (For Example: See Figure 3a);
- b) a collector region (11) of a second conductivity type, which is defined by isolation regions (17) on the semiconductor substrate (For Example: See Figure 3a);
- c) a first base (21b) semiconductor layer of the first conductivity type formed of a silicon germanium (SiGe) layer, which extends across the upper surface of the collector region to the upper surface of the isolation regions (Note: Although the prior art does not specifically disclose extends from the upper surface of the collector region to the upper surface of the isolation regions, it does disclose the base layer and isolation layer at the same level as disclosed in Applicants invention. The base layer "extends" from both layers as disclosed in Applicant's invention.) (For Example: See Figure 3a);
- d) an emitter region (35) of the second conductivity type formed on the first base semiconductor layer to contact the first base semiconductor layer in a region which is defined by emitter insulating layers (37) formed on the first base semiconductor layer (For Example: See Figure 3a and Figure 3c);
- e) second base semiconductor layers (21a) of the first conductivity type formed of a silicon layer, which is formed on the portions of the first base semiconductor layer except for the portions having the emitter region and the emitter insulating layers (For Example: See Figure 3a);

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f) an emitter electrode (39) formed on the emitter region (For Example: See Figure 3c); and

g) base electrodes (29) formed on the second base semiconductor layers at both sides of the emitter electrode (For Example: See Figure 3b).

In regards to claim 1, Ryum fails to disclose the following:

a) a base ohmic layers formed on the second base layers.

However, Arai discloses the use of a base ohmic layer (15) on base layer (14B) (For Example: See Figure 1). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor of Ryum to include the use of a base ohmic layer on base layer as disclosed in Arai because it aids in reducing base resistance (For Example: See Paragraph 90).

Additionally, since Ryum and Arai are both from the same field of endeavor, the purpose disclosed by Arai would have been recognized in the pertinent art of Ryum.

In regards to claim 2, Ryum fails to disclose the following:

a) the second base semiconductor layers are formed of an epitaxial growing layer.

Finally, the following limitation makes it a product by process claim: a) "second base semiconductor layers are formed of an epitaxial growing layer." The MPEP § 2113, states, "Even though product -by[-] process claims are limited by and defined by the process, determination of patentability is based upon the product itself. The patentability of a product does not depend on its method of production. If the product in product-by-process claim is the same as or obvious from a product of the prior art, the claim is unpatentable even though the prior product is made by a different process." *In re Thorpe*, 227 USPQ 964, 966 (Fed. Cir. 1985)(citations omitted).

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A "product by process" claim is directed to the product per se, no matter how actually made, In re Hirao and Sato et al., 190 USPQ 15 at 17 (CCPA 1976) (footnote 3). See also In re Brown and Saffer, 173 USPQ 685 (CCPA 1972): In re Luck and Gainer, 177 USPQ 523 (CCPA 1973); In re Fessmann, 180 USPQ 324 (CCPA 1974); and In re Marosi et al., 218 USPQ 289 (CAFC 1983) final product per se which must be determined in a "product by, all of" claim, and not the patentability of the process, and that an old or obvious product, whether claimed in "product by process" claims or not. Note that Applicant has the burden of proof in such cases, as the above caselaw makes clear.

In regards to claim 3, Ryum discloses the following:

a) the first conductivity type is p type and the second conductivity type is n-type (For Example: See Figure 3).

In regards to claim 6, Ryum fails to disclose the following:

a) a base ohmic layers are formed of metal silicide.

However, Arai discloses the use of a base ohmic layer (15) made of metal silicide (For Example: See Paragraph 80). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor of Ryum to include the use of a base ohmic layer made of metal silicide as disclosed in Arai because it aids in reducing base resistance (For Example: See Paragraph 90).

Additionally, since Ryum and Arai are both from the same field of endeavor, the purpose disclosed by Arai would have been recognized in the pertinent art of Ryum.

4. Claims 4 and 5 are rejected under 35 U.S.C. 103(a) as obvious over Ryum et al. (U.S. Publication No. 2002/0058388) in view of Arai (U.S. Publication No. 2004/023526) and Kameyama (U.S. Patent No. 5,183,768).

In regards to claim 4, Ryum fails to disclose the following:

a) first selectively ion implanted collector (SIC) regions of the second conductivity type, which are formed at portions near the surface of the collector region and adjacent to the isolation regions.

However, Kameyama et al. ("Kameyama") discloses the use of a SIC region of a second conductivity type (120A) which are formed at portions near the surface of the collector region (104) and adjacent to the isolation regions (106) (For Example: See Figure 4d). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor of Ryum to include the use of a SIC region as disclosed in Kameyama because it aids in improving the speed of the transistor (For Example: See Column 1 Lines 32-37).

Additionally, since Ryum and Kameyama are both from the same field of endeavor, the purpose disclosed by Kameyama would have been recognized in the pertinent art of Ryum.

In regards to claim 5, Ryum fails to disclose the following:

a) a second SIC region of the second conductivity type, which is formed in a portion of the collector region under the emitter region.

However, Kameyama discloses the use of a second SIC region (120B) of a second conductivity type formed in a portion of the collector region under the emitter region (140A) (For Example: See Figure 4d). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor of Ryum to include the use of a

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SIC region as disclosed in Kameyama because it aids in improving the speed of the transistor (For Example: See Column 1 Lines 32-37).

Additionally, since Ryum and Kameyama are both from the same field of endeavor, the purpose disclosed by Kameyama would have been recognized in the pertinent art of Ryum.

5. Claim 7 is rejected under 35 U.S.C. 103(a) as obvious over Ryum et al. (U.S. Publication No. 2002/0058388) in view of Arai (U.S. Publication No. 2004/023526) and Josquin (U.S. Patent No. 5,023,192).

In regards to claim 7, Ryum fails to disclose the following:

a) the base ohmic layers are formed of one of titanium silicide and cobalt silicide.

However, Josquin et al. ("Josquin") discloses the use of base ohmic layers formed of one of titanium silicide and cobalt silicide (For Example: See Column 7 Lines 52-54). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor of Ryum to include the use of titanium silicide and cobalt silicide as disclosed in Josquin because it aids in improving ohmic contact (For Example: See Column 7 Lines 52-54).

Additionally, since Ryum and Josquin are both from the same field of endeavor, the purpose disclosed by Josquin would have been recognized in the pertinent art of Ryum.

6. Claims 8 and 9 are rejected under 35 U.S.C. 103(a) as obvious over Ryum et al. (U.S. Publication No. 2002/0058388) in view of Arai (U.S. Publication No. 2004/023526) and Ryum et al. (U.S. Patent No. 5,798,277).

In regards to claim 8, Ryum fails to disclose the following:

a) insulating layers formed between the isolation regions and the first base semiconductor layer, under the base electrodes.

However, Ryum et al. ("Ryum") discloses the use of insulating layers (12 and 13) formed between the isolation regions (3) and the first base semiconductor layer (19), under the base electrodes (For Example: See Figure 4). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor of Ryum to include the use of insulating layers as disclosed in Ryum because it aids in enhancing the reliability of the device (For Example: See Column 6 Lines 16-20).

Additionally, since Ryum and Ryum are both from the same field of endeavor, the purpose disclosed by Ryum would have been recognized in the pertinent art of Ryum.

In regards to claim 9, Ryum fails to disclose the following:

a) insulating layers are formed of one of oxide layers and nitride layers.

However, Ryum discloses the use of oxide and nitride layers (For Example: See Column 6 Lines 16-20). It would have been obvious to one having ordinary skill in the art at the time the invention was made to modify the semiconductor of Ryum to include the use of oxide and nitride layers as disclosed in Ryum because it aids in enhancing the reliability of the device (For Example: See Column 6 Lines 16-20).

Additionally, since Ryum and Ryum are both from the same field of endeavor, the purpose disclosed by Ryum would have been recognized in the pertinent art of Ryum.

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Response to Arguments

7. Applicant's arguments filed 5/6/05 have been fully considered but they are not persuasive. Applicant argues that "none of the references teaches or suggests second base semiconductor layers formed on the portions of a first base semiconductor layer except for the portions having an emitter region and emitter insulating layers." However, Ryum discloses second base semiconductor layer (21a) of the first conductivity type formed of a silicon layer is formed on the portions of the first base semiconductor layer (21b) except for the portions having the emitter region (35) and the emitter insulating layers (37) (For Example: See Figure 3a)

Allowable Subject Matter

- 8. Claims 21-28 are allowed.
- 9. Claim 10 is objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Conclusion

10. THIS ACTION IS MADE FINAL. Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event,

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however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

11. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Monica Lewis whose telephone number is 571-272-1838.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Amir Zarabian can be reached on 571-272-1852. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300 for regular and after final communications. Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is 703-308-0956.

ML August 3, 2005

> Mary Wilczewski Primary Examiner